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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

JINNO et al.

Serial No.: 09/753,397

Filed: January 3, 2001

Atty. File No.: 2933SE-62-DIV

For: "THIN FILM TRANSISTOR AND  
METHOD OF FABRICATING THE  
SAME"Commissioner of Patents  
Washington, D.C. 20231

Group Art Unit:

Examiner:

**NOTICE OF CLAIM FOR FOREIGN  
PRIORITY BENEFITS UNDER  
35 U.S.C. §119**

## CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE OR FEE IS  
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TO ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON,  
D.C. 20231 ON THIS 21 DAY OF Feb, 2001.

BY: Aimee Thuek SHERIDAN ROSS P.C.

Dear Sir:

As stated in the transmittal sheet submitted in connection with the above-identified patent application, foreign priority benefits are claimed under 35 U.S.C. §119 of Japanese Patent Application Serial No. 8-350619 filed December 27, 1996. Certified priority documents, which have been accepted by the U.S. Patent and Trademark Office, were filed in connection with the parent of the present patent application, U.S. Patent Application Serial No. 08/997,763 filed December 24, 1997. Applicants respectfully request that the Examiner acknowledge the claim for priority.

Respectfully submitted,

SHERIDAN ROSS P.C.

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Date: February 21, 2001